

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

**Title of
Invention**

POLISHING INHIBITING LAYER FORMING ADDITIVE,
SLURRY AND CMP METHOD

Application Number :

Confirmation Number:

First Named Applicant: Michael MacDonald

Attorney Docket Number: FIS920040163

Art Unit:

Examiner:

Search string: (6514862).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6514862	2003-02-04	Lee et al.			

Signature

Examiner Name	Date